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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/765,808	01/27/2004	Huang-Ming Chen	N1085-00256 [TSMC2003-08	2454
54657	7590 11/10/2005		EXAM	INER
DUANE MORRIS LLP			CHEN, KIN-CHAN	
IP DEPARTI	MENT (TSMC)			
30 SOUTH 17TH STREET			ART UNIT	PAPER NUMBER
PHILADELPHIA, PA 19103-4196			1765	
			DATE MAIL ED. 11/10/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	Z
Office Action Summary		10/765,808	CHEN ET AL.	
		Examiner	Art Unit	
		Kin-Chan Chen	1765	
Period fo	The MAILING DATE of this communication apport	pears on the cover sheet with the c	correspondence address	
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPLICHEVER IS LONGER, FROM THE MAILING DISTRICT INTO THE MAILING DEPLY WILLIAM THE MAILING DEPLY WILLIAM THE MAILING DEPLY WILLIAM THE MAILING THE MAILING DEPLY WILLIAM THE MAILING THE MAILI	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin will apply and will expire SIX (6) MONTHS from to cause the application to become ABANDONE	N. nety filed the mailing date of this communication. D (35 U.S.C. § 133).	
Status				
1)	Responsive to communication(s) filed on	-··		
2a)□	This action is FINAL . 2b)⊠ This	action is non-final.		
3)	Since this application is in condition for allowa	nce except for formal matters, pro	osecution as to the merits is	
	closed in accordance with the practice under \boldsymbol{k}	Ex parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.	
Dispositi	ion of Claims			
4)🖂	Claim(s) 1-28 is/are pending in the application			
	4a) Of the above claim(s) is/are withdra	wn from consideration.		
•	Claim(s) is/are allowed.		•	
6)	Claim(s) is/are rejected.			
7) 📙	Claim(s) is/are objected to.			
8)⊠	Claim(s) <u>1-28</u> are subject to restriction and/or	election requirement.		
Applicati	ion Papers			
-	The specification is objected to by the Examine			
10)	The drawing(s) filed on is/are: a) acc	epted or b) \square objected to by the	Examiner.	
	Applicant may not request that any objection to the	- · ·		
	Replacement drawing sheet(s) including the correc	- · ·	=	
11)	The oath or declaration is objected to by the E	xaminer. Note the attached Office	Action or form PTO-152.	
Priority (under 35 U.S.C. § 119			
•	Acknowledgment is made of a claim for foreigr ☐ All b) ☐ Some * c) ☐ None of:	ı priority under 35 U.S.C. § 119(a)-(d) or (f).	
,	1. Certified copies of the priority document	s have been received.		
	2. Certified copies of the priority document		ion No	
	3. Copies of the certified copies of the price	rity documents have been receive	ed in this National Stage	
	application from the International Burea	u (PCT Rule 17.2(a)).		
* (See the attached detailed Office action for a list	of the certified copies not receive	ed.	
Attachmen	nt(s)			
	ce of References Cited (PTO-892)	4) Interview Summary		
3) Infor	ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) er No(s)/Mail Date	Paper No(s)/Mail D 5) Notice of Informal F 6) Other:	ate Patent Application (PTO-152)	
I.S. Patent and T	Frademark Office			

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DETAILED ACTION

Election/Restrictions

- 1. Restriction to one of the following inventions is required under 35 U.S.C. 121:
 - Claims 1-13, drawn to an etching apparatus, classified in class 156, subclass 345.
 - II. Claims 14-28, drawn to an etching process, classified in class 438, subclass 706.
- 2. The inventions are distinct, each from the other because of the following reasons:

Inventions II and I are related as process and apparatus for its practice. The inventions are distinct if it can be shown that either: (1) the process as claimed can be practiced by another materially different apparatus or by hand, or (2) the apparatus as claimed can be used to practice another and materially different process. (MPEP § 806.05(e)). In this case the apparatus as claimed can be used to practice another and materially different process such as plasma deposition.

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.

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Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of inventorship must be accompanied by a request under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(i).

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kin-Chan Chen whose telephone number is (571) 272-1461. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

November 4 2005

Kin-Chan Chen

Primary Examiner
1765